

U.S. Department of Commerce, Patent and Transferred					Docket N	Docket No.: 3829.01			
					Serial No	Serial No.: 10/618,078			
LIST OF RELEVANT ART CITED BY APPLICANT					Applican	Applicant: Charles E. BRYSON, III et al.			
(Use several sheets if necessary)					Filing Da	Filing Date: July 11, 2003 Group: 2881			
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*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date Appropriate		
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	AL								
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JB	AN	L. E. Trimble et al., "Membrane fragility: fact or illusion?", J. Vac. Sci. Technol. B, vol. 10, no. 6, Nov/Dec 1992, 3200-3203 pp.							
913	AO	T. Kramer et al., "Postbuckled micromachined square membranes under differential pressure", Journal of Micromechanics and Microengineering" vol. 12, 2002, 475-478 pp.							
913	AP	N. J. Lanno et al., "Measurement of the permeability of thin films", Review of Scientific Instruments", vol. 70, no. 4, April 1999, 2072-2073 pp.							
9B 9B 9B	AQ	Jinling Yang et al., "Fracture properties of LPCVD silicon nitride thin films from the load-deflection of long membranes", Sensors and Actuators A, vol. 97, no. 98, 2002, 520-526 pp.							
9/3	AR	D. Maier-Schneider, "A new analytical solution for the load-deflection of square membranes", Journal of Microelectromechanical Systems, vol. 4, no. 4, December 1995, 238-241 pp.							
	AS								
Examiner Jack Borman			Date Considered 6/29/04						
				or not citation is in conform is form with your communic			ine through cita	ation if not	